



Attorney Patent Dkt. No.: 257/040US
P00-0022
54006.8014.US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Bryer, James

Serial No.: 09/658,395

Filed: September 8, 2000

For: SPRAY NOZZLE SYSTEM FOR A
SEMICONDUCTOR WAFER CONTAINER
CLEANING APPARATUS

) Group Art Unit: 1746

) Examiner: Zeinab El-Arini

11/B
AS
1/18/02
RECEIVED
JAN 0 2 2003
TC 1700

AMENDMENT AND RESPONSE

Commissioner for Patents
Washington, D.C. 20231

Sir:

In reply to the September 18, 2002 Office Action, please amend the above-identified application as follows:

IN THE CLAIMS

Claims 2, 4, 5, 7, and 8 have been cancelled. Claims 3, 6, 12, 13, 14, and 16 have been amended as indicated in the attached marked up claim sheets. New claims 17-20 have been added as shown in the attached clean set of pending claims.

12/30/2002 MDANTE1 00000046 09658395

01 FC:1201

168.00 0P

B